- --38.(once amended) [An] <u>The</u> electroluminescent device of claim 22, wherein both hole-transporting layer and CNC layer is substituted by a viscous composite comprising of CNCs, hole-transporting organic semiconductors, oxidative agents, soluble salts and [low] <u>lower than</u> <u>atmospheric</u> vapor pressure viscosity-modifying agents
- 39. [An] <u>The</u> electroluminescent device of claim 38, wherein viscous composite is contained within appropriate openings realized between [said elastomeric] spacers, <u>which are made of hole transporting viscous composite</u>.
- 40. [An] <u>The</u> electroluminescent device of claim 39, wherein the holes in said [elastomeric] spacers are filled with said viscous composite with distinct emission characteristics.
- 41. [An] <u>The EL device as described in claim 40</u>, wherein the viscous composites [is] <u>are</u> introduced by [a] method <u>selected from the group consisting of</u> [such as] screen-printing and ink-jet printing.
- 42. An [electroluminescent (EL) device, of claim 1, where in *p-n* junction is replaced by an *p-n* junction electroluminescent device comprising successive layers of:

an *n*-type silicon layer on <u>an</u> insulator substrate, comprising thin doped Si  $n/n^+$  regions separated by insulating regions, such as SiO<sub>2</sub>, wherein said n+ regions are contacted to form bottom electrodes;

a thin-layer of Si allowing for further epitaxial growth;

an  $n^+$ -type Si layer, [the said layer has] <u>having</u> addressing contact electrodes;

a thin (about 10 nm) SiO<sub>2</sub> layer [is deposited], which is <u>deposited and</u> patterned with a pitch of about 0.1microns;

a p-Si layer forming nanotips;

an *n*-type wide energy gap layer selected from [a] the group of semiconductors [such as] consisting of: Zn<sub>a</sub>Mg<sub>1-a</sub>Se, Zn<sub>a</sub>Mg<sub>1-a</sub>S, Zn<sub>a</sub>Mg<sub>1-a</sub>S<sub>b</sub>Se<sub>1-b</sub>, Zn<sub>a</sub>Be<sub>1-a</sub>S<sub>b</sub>Se<sub>1-b</sub>, Al<sub>c</sub>Ga<sub>1-c</sub>N, ZnMgBeSe, AlInN, stacked on the layer comprising of nanotips;

a layer comprising of cladded quantum dots;

an *n*-type [wider] wide gap semiconductors layer selected from the semiconductors consisting of: Zn<sub>a</sub>Mg<sub>1-a</sub>Se, Zn<sub>a</sub>Mg<sub>1-a</sub>S, Zn<sub>a</sub>Mg<sub>1-a</sub>S<sub>b</sub>Se<sub>1-b</sub>, Zn<sub>a</sub>Be<sub>1-a</sub>S<sub>b</sub>Se<sub>1-b</sub>, Al<sub>c</sub>Ga<sub>1-c</sub>N, ZnMgBeSe, AlInN; and

a layer forming contact electrodes, wherein said set of electrodes are appropriately biased and addressed to create a two-dimensional display.